

Notice of References Cited	Application/Control No. 09/943,078	Applicant(s)/Patent Under Reexamination ABBOTT, TODD R.	
	Examiner Erik Kielin	Art Unit 2813	Page 1 of 1

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	M	US-			

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	V	Van Zant, Microchip Fabrication, 4th ed. McGraw-Hill: New York, 2000, p. 199.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.